Polarization errors associated with birefringent waveplates

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Abstract. Although zero-order quartz waveplates are widely used in instrumentation that needs good temperature and field-of-view characteristics, the residual errors associated with these devices can be very important in high-resolution polarimetry measurements. How the field-of-view characteristics are affected by retardation errors and the misalignment of optic axes in a double-crystal waveplate is discussed. The retardation measurements made on zero-order quartz and single-order "achromatic" waveplates and how the misalignment errors affect those measurements are discussed.

Subject terms: polarization analysis and measurement; waveplates; retardation; polarimetry.

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1 Introduction

In almost any device that measures polarization, waveplates seem to be a necessary evil. They may be used as one of the active elements in a polarization analyzer (for example, a rotating quarter-wave plate\textsuperscript{1}) or in the calibration of the polarization analyzer (for example, KD\textsubscript{2}P electro-optic crystal\textsuperscript{2}). As the accuracy of polarization measurements is pushed below $10^{-2}$, errors that might normally be neglected in waveplates become important, and determining the source of those errors so that models can be developed to study and eliminate them becomes a complicated task.

In instruments that measure polarized light very accurately, "known" polarizations are used as the input source, measurements are made with the polarimeter, and the Mueller matrix relating the input to the output is determined. This paper discusses the test equipment used and the data that were obtained on quarter-wave plates, which will be used in the development of a polarimeter for solar magnetic field measurements. Section 2 describes the test equipment and some of the problems that occurred in determining the absolute retardance. Section 3 describes the errors associated with multiple plate retarders and Sec. 4 presents the data that were obtained on the experimental vector magnetograph (EXVM) waveplates.

2 Test Equipment

Figure 1 shows the optical components that were used in the retardation measurements. One of the main problems in testing any polarization element is obtaining a perfect input polarizer and a perfect analyzer. In the visible spectrum, prism polarizers have the highest polarization resolution. To produce a "perfect" polarization source, two Glan-Thompson polarizers were aligned in parallel and were placed in front of the waveplate to be tested. The "perfect" analyzer was the EXVM polarimeter which consists of a Glan-Thompson polarizer and an HN32 Polaroid whose transmission axes were also aligned parallel\textsuperscript{4}.

A multiline HeNe laser was used as the light source and a beam expander was added to the laser to produce a 13-mm collimated beam. A shutter and an achromatic waveplate were placed between the linearly polarized laser and the calibration polarizer.

A photomultiplier (PM) tube was used as the detector. The PM tube was selected because of its sensitivity to low light levels. Because PM tubes are not known for their linearity and the input source (the multiline HeNe laser) was not stable,
Polarization Errors Associated with Birefringent Waveplates

A Soleil-Babinet compensator was used to measure the retardation of the EXVM waveplates. To minimize detector and source errors, all calibration points and retardation measurements were made at minimum signal levels and as rapidly as possible. With the detector and source errors minimized, the Soleil-Babinet compensator became the next critical error source.

In the following discussion, “optical axis” refers to the propagation direction of the light. “Optic axis” refers to the direction in a birefringent crystal in which there is no phase retardation for light propagating along that axis. For biaxial crystals, there are two “optic axes.” For uniaxial crystals, which are used in the construction waveplates, there is one optic axis direction and it is parallel to the extraordinary index of refraction \( n_e \). Therefore, to change polarized light, the “optic axis” of a waveplate is perpendicular to the “optical axis” of the lens system.

The optical components of a Soleil-Babinet compensator are shown in Fig. 2. The compensator consists of three quartz plates, one plane parallel plate and two plates with a 2.5 deg wedge. The optic axis (OA) of the parallel plate is perpendicular to the optic axes of the two wedge plates, and one of the wedge plates is allowed to move. The parallel plate has a fixed retardance, whereas the two wedges form a variable waveplate whose retardance is dependent on the total thickness of the two wedges. The parallel plate retarder is combined with the wedge retarder to minimize the variation of retardance over the field of view. As one would expect, the main error in the Soleil-Babinet compensator is the positioning of the moveable wedge. These include both rotational misalignment errors of the optic axes of the two wedges and translational errors (a thickness/optical path error, which translates into a retardation error). To minimize the translation and rotational errors in the compensator, the moveable waveplate was only allowed to move in one direction to minimize mechanical backlash in its positioning. Finally, the compensator was calibrated before and after every set of fast axis retardation measurements (at 45, 135, 225, and 315 deg) made on the test waveplate. This was done to eliminate any systematic dc offsets in the retardation measurements.

3 Modeling Retarder Errors

There are some errors that depend on the quality control in the construction phase of the retarder that are difficult to model and are neglected here. One error that is neglected is the crystalline structure of the birefringent material used to produce the waveplate. This error is dependent on the experience of the optician and the availability of high-quality crystals. Other errors are related to the manufacturing process such as roll-off effects at the edge and stress-induced birefringence. Because these errors are dependent on the experience of the company manufacturing the waveplates (and the user to detect them), they are neglected and the following assumptions are made: (1) there is no variation in the optical properties in the birefringent crystals used to produce the waveplates, (2) the aperture size of the retarder is much larger than the incident light so that edge effects can be neglected, and (3) the waveplates forming the retarder have parallel surfaces. The remaining errors are thickness, field-of-view errors, optic axis tilt errors, and fast axis misalignments. These errors are shown in Fig. 3. Before describing these errors, a short discussion on the two types of waveplates that were selected for use in the EXVM polarimeter is in order.

3.1 Description of the EXVM Waveplates

Figure 4 shows the structure of the zero-order and achromatic waveplates used in the EXVM magnetograph. The zero-order waveplates are standard quartz waveplates in which the optic axes (the extraordinary indices, \( n_e \) and \( n'_e \), in Fig. 4) of the two quartz crystals are perpendicular to the propagation of the light (optical axis) and are separated by 90 deg. This orientation minimizes field-of-view errors and the retardation is simply related to the difference in the thickness of the two plates. Although the relationship of retardance to thickness is normally written as

\[
\delta = \frac{2\pi (n_e - n'_e)(\Delta d)}{\lambda}, \tag{1}
\]

we use a longer notation so that the errors to be discussed can be related to that equation. Therefore, the equation for a zero-order or achromatic retarder is written in the form

\[
\delta = \frac{2\pi (n_y - n_x)\Delta d_1 + 2\pi (n'_y - n'_x)\Delta d_2}{\lambda}, \tag{2}
\]

or

\[
\delta = \delta_1 + \delta_2, \tag{3}
\]

where \( n_x \) is the ordinary index of refraction, \( n_y \) is the extraordinary, and \( \delta_1 \) is the total retardance of the first waveplate (WP1). Similarly, \( n'_y \) is the ordinary, \( n'_x \) the extraordinary, and \( \delta_2 \) the total retardance of the second waveplate (WP2).
The achromatic waveplates have the same optic axis alignment as the quartz waveplates, but one of the quartz plates is replaced with a magnesium fluoride (MgF$_2$) plate. Both quartz and MgF$_2$ are positive uniaxial crystals ($n_e > n_o$). Although termed an achromatic waveplate, the design goal was to achieve a quarter-wave retardance at 5250 and 6302 Å. Therefore, the thicknesses for the MgF$_2$ and quartz plates were adjusted to meet those design specifications. Table 1 shows the optical properties that would be required to obtain perfect zero-order and achromatic waveplates. Figure 5 shows how the retardance of these waveplates varies with wavelength. These perfect waveplates are used to demonstrate how the various errors affect the performance of the EXVM retarders.

3.2 Thickness Error

The thickness error for a zero-order quartz waveplate is simply a dc offset, or shift in the retardation axis for the curves in Fig. 5. If the thickness of the first waveplate (WP1 in Table 1) is smaller (or larger) than the specification, the thickness of the second waveplate (WP2) is simply adjusted in the same way. The importance is in the difference in thickness, not the total thickness. For achromatic waveplates, however, the thickness tolerance is very critical if the achromat is to be quarter-wave at 5250 and 6302 Å. This results from the fact that there are only two independent equations (6 at 5250 and 6302 Å) and two unknowns ($d_1$ and $d_2$), for the achromatic waveplates. In the zero-order waveplates, there is one equation (6 at 5250 Å) and one unknown ($\Delta d$, which is equal to $d_1 - d_2$). Therefore, a thickness error in the EXVM achromatic waveplates is much more critical than a thickness error in the zero-order quartz waveplates. Figure 6 shows how the order of an achromatic waveplate affects its retardation versus wavelength properties. Varying the order ($m \times 360$ deg, where $m$ is the order and $m = 0,1,2,...$) of the waveplate allows the total thickness to change while the thickness ratio remains constant.

3.3 Field-of-View Errors

Field-of-view errors exist in all birefringent elements. The birefringent property that enables creating a phase shift in a retarder is also the same property that limits its field of view. The field-of-view errors are related to the birefringence ($n_e - n_o$) of the crystal, its thickness ($d_1, d_2$), and the direction of the incident light. Assume that $\alpha + 90$ deg is the angle that the light makes relative to the optic axis of the first crystal (WP1) and that $\beta + 90$ deg is the angle relative to the optic axis of the second crystal (WP2) and that $\alpha$ and $\beta$ lie in orthogonal planes (see Fig. 7), then the maximum field-of-
Table 1 Optical properties of ideal quarter-wave plates for use in the EXVM polarimeter. The values are at 5250.2 Å and 22°C.

<table>
<thead>
<tr>
<th>Retarder</th>
<th>Plate #</th>
<th>Material</th>
<th>$n_x$</th>
<th>$n_y$</th>
<th>$n_x - n_y$</th>
<th>$d$</th>
<th>$\delta$</th>
</tr>
</thead>
<tbody>
<tr>
<td>Zero-order</td>
<td>WP1</td>
<td>quartz</td>
<td>1.5473</td>
<td>1.5565</td>
<td>-9.207e-3</td>
<td>2.5413</td>
<td>-16044</td>
</tr>
<tr>
<td></td>
<td>WP2</td>
<td>quartz</td>
<td>1.5565</td>
<td>1.5473</td>
<td>+9.207e-3</td>
<td>2.5270</td>
<td>+15954</td>
</tr>
<tr>
<td>Achromatic</td>
<td>WP1</td>
<td>quartz</td>
<td>1.5473</td>
<td>1.5565</td>
<td>-9.207e-3</td>
<td>1.612</td>
<td>-10171</td>
</tr>
<tr>
<td></td>
<td>WP2</td>
<td>MgF₂</td>
<td>1.3909</td>
<td>1.3791</td>
<td>+1.186e-2</td>
<td>1.305</td>
<td>+10621</td>
</tr>
</tbody>
</table>

Fig. 5 Variation of retardance with wavelength for perfect zero-order and achromatic quarter-wave plates. For the achromatic waveplates the thicknesses were chosen so that the retarder would be a perfect 90 deg (+360 deg) retarder at 5250 and 6302 Å.

Fig. 6 Variation of retardance in a quartz/MgF₂ achromatic waveplate with the order $m$ (90 deg + $m \times 360$ deg).

Fig. 7 Schematic showing how the retardation $\delta$ varies with the angle of incidence of the light relative to the optic axes of WP1 and WP2. The dotted lines in the retardance map represent the on-axis retardance [here assumed to be $\delta(0,0) = -90$ deg]. The dark contours are retardance values relative to this on-axis retardance, for example $\delta(0$ deg, 0 deg) + $\delta(8$ deg, 0 deg) = 0 deg. The field-of-view errors of the 0-deg contour cancel out the on-axis retardance. Similar to that of the retardation map shown in Fig. 7. Figure 8 shows how the retardance varies with the angle of incidence for achromatic and zero-order retarders.

Two points shown in Fig. 7 should be emphasized. First, the retardation $\delta(\alpha, \beta)$ is dependent only on the magnitude of the angle between the optic axis (WP1 and WP2) and the optical axis, for example, $\delta(-1$ deg, 0 deg) = $\delta(-1$ deg, 0 deg) and $\delta(0$ deg, +1 deg) = $\delta(0$ deg, -1 deg). Second, the retardation error becomes smaller as the angle between the optical axis and the two optic axes becomes equal, $\delta(0$ deg, 0 deg) - $\delta(0,0)$ as $|\alpha| -|\beta|$.  

3.4 Optic Axis Tilt Errors

Although the optic axis tilt errors are related to the field-of-view errors, they are created when the optic axes are not perpendicular to the propagation direction of the light (z axis/optical axis). Figure 9 shows four different ways errors
in the alignment of the optic axes can affect the retardation measurements. In these simulations, the waveplate is mounted in a rotary stage so that measurements can be made at the four fast axis positions, 45, 135, 225, and 315 deg. This rotary stage is then allowed to tilt the waveplate with respect to the z axis. In these simulations, the mechanical tilt (z axis tilt in Fig. 9) was selected to maximize the retardation errors, namely, in the planes containing the WP1 or WP2 optic axes, (α, 0) or (0, β) in Fig. 7.

The first optic axis error assumes that the optic axes of WP1 and WP2 are not parallel to the polished surfaces. The effect of this error is shown in Fig. 9(a). In this case, the light is assumed to be propagating along the z axis, and the polished surfaces of the waveplates are perpendicular to that direction (z axis tilt = 0 deg). Even though the light is parallel to the z axis there will be a positive error if the optic axis of WP1 is not perpendicular to the z axis [Fig. 9(a), α = ±1 deg, β = 0 deg curve], a negative retardation error if the optic axis of WP2 is tilted [Fig. 9(a), α = 0 deg, β = ±1 deg curve], and no retardation error if the optic axes of WP1 and WP2 are at the same angle (|α| = |β|). When the optic axis tilt errors are equal, the two retardation errors cancel out and the errors will not be detected.

Figures 9(b) and 9(c) demonstrate the best way to test waveplates to determine if optic axis tilt errors exist. In Fig. 9(b), it is assumed that there are no optic axis tilt errors in WP1 and WP2. The rotary stage, which holds the retarder, is tilted 2 deg (z axis tilt) with respect to the plane containing the optic axes. In this case, the retardation measurements taken at the fast axis positions 45, 135, 225, and 315 deg are not equal. In Fig. 9(c), the optic axis tilt errors are equal, and the retardation measurements taken at the fast axis positions 45, 135, 225, and 315 deg are not equal. In Fig. 9(d), the optic axis tilt errors are not equal, and the retardation measurements taken at the fast axis positions 45, 135, 225, and 315 deg are not equal.

Figures 9(a), 9(b), 9(c), and 9(d) demonstrate the effects of optic axis errors on the retardation measurements. In Fig. 9(a), the optic axes of WP1 and WP2 are not parallel to the polished surfaces. The effect of this error is shown in Fig. 9(a). In this case, the light is assumed to be propagating along the z axis, and the polished surfaces of the waveplates are perpendicular to that direction (z axis tilt = 0 deg). Even though the light is parallel to the z axis there will be a positive error if the optic axis of WP1 is not perpendicular to the z axis [Fig. 9(a), α = ±1 deg, β = 0 deg curve], a negative retardation error if the optic axis of WP2 is tilted [Fig. 9(a), α = 0 deg, β = ±1 deg curve], and no retardation error if the optic axes of WP1 and WP2 are at the same angle (|α| = |β|). When the optic axis tilt errors are equal, the two retardation errors cancel out and the errors will not be detected.

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either the WP1 or WP2 optic axis. Now as the retarder is rotated to its fast axis locations, the optic axis \( \alpha \) of WP1 will be at a +2-deg tilt when the fast axis (FA) is at 45 and 225 deg. Similarly, the optic axis \( \beta \) of WP2 will be at +2-deg when the fast axis is at 135 and 315 deg. With no optic axis tilt errors, the retardation measurements at \( \alpha = 45 \) and 225 deg should be the same [Fig. 9(b)]. The measurements at \( \alpha = 135 \) and 315 deg are also equal.

Figure 9(c) shows how internal optic axis errors affect the curves shown in Fig. 9(b). Assuming that the optic axes for WP1 and WP2 have a 1-deg tilt error, the WP1 optic axis is tilted 3 deg with respect to incident light for the 45-deg FA measurement, and at 1 deg for the 225-deg FA measurement. This difference in the optic axis position will cause the four FA measurements to separate. Therefore, an optic axis tilt error that would go unnoticed in Fig. 9(a) \( (\alpha = \beta = 1 \text{ deg}) \) could be detected if the rotation axis of the retarder is tilted with respect to the propagation direction of the light. The tilt error in Fig. 9(c) is the type that should be expected in zero-order retarders in which the birefringent material is from the same crystal. Figure 9(d) demonstrates the effects that are expected in achromatic waveplates where two different crystals (quartz and MgF\(_2\)) are used and the optic axis tilt errors \( (\alpha, \beta) \) are not expected to be equal.

### 3.5 Rotational Misalignment of the Optic Axes

If the optic axes of a retarder are exactly 90 deg apart, the retarder can be placed between crossed polarizers, its “fast” or “slow” axis aligned parallel to the polarizers, and there will be no detected signal. If a signal is detected, and if the birefringent crystals are not optically active, then there is a rotational misalignment \( (\rho \text{ in Fig. 3(d)}) \) of the WP1 and WP2 optic axes.

The perfect zero-order quartz retarder in Table 1 is now described. With the FA of waveplate WP1 at −45 deg to the analyzer, the retarder will transform right circular polarization \( (+ V) \) into elliptical polarization by creating a 16,044 deg phase shift \( (\delta = - (44 \times 360 \text{ deg} + 204 \text{ deg})) \). Because the FA of the second waveplate, WP2, is 90 deg from the FA of WP1, it will create a positive retardation of 15,954 deg. The total retardance of WP1 and WP2 is 90 deg, which will transform the incident circular polarization \( (+ V) \) into \(- V\) linear polarization. Assuming that there is an error in the alignment of the WP2 optic axis, then the circular polarization will be transformed into linear, but the linear will not be perpendicular to the analyzer (assumed to be at +Q). In effect, the retarder may be perfect \( (\delta_1 = \delta_2 = \pm 90 \text{ deg}) \), but if there is a rotational misalignment of the optic axis about the optical axis \( (\rho \text{ axis}) \), there will be linear crosstalk in the circular polarization measurement.

The main effect of this error is that the Soleil-Babinet compensator will measure two different minimum locations (or retardations) depending on whether the “fast” or “slow” axis of the retarder is aligned parallel to the input polarization. The difference in these minimum locations, which are wavelength dependent, can be used to estimate the WP2 optic axis misalignment \( (\rho) \).

### 4 Data Analysis

Although Sec. 3 describes the various errors that are possible, those errors were only considered after all of the systematic and random errors in the test setup were minimized. Even though the retarders were carefully mounted in the rotary stage and observations were made of the motion of the reflected light as the retarder was rotated through 360 deg, each FA measurement (45, 225, 135, and 315 deg) had retardation values that were not equal, and repeated systematically. Only after tilting the retarders in an effort to obtain a perfect 90-deg phase retardance did the errors in Sec. 3 become obvious.

Each retarder was measured at a minimum of four mechanical or \( z \) axis tilt angles, where \( \alpha \) and \( \beta \) denote the orientation of the rotation stage. The mechanical tilt angle \( \alpha \), is in the same plane as the WP1 optic axis tilt angle \( \alpha \). Similarly, \( \beta \), is in the same plane as the WP2 optic axis \( \beta \).

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Table 2 Parameters that characterize the quarter-wave plates that were tested for use in the EXVM polarimeter. The FA error of WP1 was assumed to be zero.

<table>
<thead>
<tr>
<th>Retarder #</th>
<th>Type</th>
<th>Retardance at 525 nm (degrees)</th>
<th>Rotational misalignment (degrees)</th>
<th>Optic axis tilt error (degrees)</th>
<th>Birefringence error ( \Delta(n_x - n_y) )</th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td>WP2 ((\rho))</td>
<td>WP1 ((\alpha))</td>
<td>WP2 ((\beta))</td>
<td></td>
<td></td>
</tr>
<tr>
<td>QWP1</td>
<td>achromat</td>
<td>452.3 ± 0.6</td>
<td>0.5 ± 0.2</td>
<td>0.07 ± 0.04</td>
<td>0.95 ± 0.05</td>
</tr>
<tr>
<td>QWP2</td>
<td>achromat</td>
<td>451.1 ± 0.2</td>
<td>0.5 ± 0.1</td>
<td>0.08 ± 0.05</td>
<td>1.37 ± 0.07</td>
</tr>
<tr>
<td>QWP4</td>
<td>zero</td>
<td>91.3 ± 0.1</td>
<td>1.1 ± 0.2</td>
<td>0.07 ± 0.04</td>
<td>0.04 ± 0.02</td>
</tr>
<tr>
<td>QWP5</td>
<td>zero</td>
<td>88.9 ± 0.2</td>
<td>0.7 ± 0.02</td>
<td>0.11 ± 0.02</td>
<td>—</td>
</tr>
</tbody>
</table>

With collimated beams, each image point has a "constant" field-of-view error associated with it. This error is easy to model and can be removed from the measured polarization.

References

Edward A. West received his BS degree in engineering science from Tennessee Technological University in 1973 and his MS degree in electrical engineering from the University of Alabama in Huntsville in 1982. He joined NASA/Marshall Space Flight Center in the fall of 1973 and has been associated with the Space Science Laboratory since that time. His research interests are in the development of stable high-resolution polarimeters for both ground-based and space-based solar magnetographs and in the development of real-time analysis techniques for use in studies on solar magnetic field evolution and flare prediction.

Matthew H. Smith received his BS degree in applied optics from the Rose-Hulman Institute of Technology in 1991 and his MS degree in physics from the University of Alabama in Huntsville (UAH) in 1993. He is currently pursuing his PhD in physics at UAH, where his research interests include optical system design and testing of solar vector magnetographs and retinal imaging instruments.